## PI



Nanopositioning for Microscopy
FAST, COMPACT, TO THE NANOMETER

## Nanopositioning for Microscopy

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## Precision Positioning is the Key Element in all Types of Microscopy

High-resolution microscopy techniques must be capable of accurate and reproducible positioning of imaging elements or samples. Applications range from precise $z$-focus positioning of light microscope objectives in the depths of field, to exact positioning of tiny biological samples for 4Pi Resolft 2-Photon super-resolution fluorescence microscopy. Also in atomic force microscopy (AFM), electron microscopy (SEM and TEM) and correlative microscopy, PI's versatile nanopositioning solutions greatly support even the most demanding positioning tasks.


# Routine Widefield Microscopy 

Examination of Stained Tissue Slices on Slides


When analyzing tissue samples with a motorized microscope, an accurate autofocus in the depth of field is crucial for interpretable images. Reliable diagnostic results of histological slide, blood smears, and gynecological pap smears depend directly on the performance of the microscope system. PI offers ideally matched components for positioning the objective in $Z$ direction as well as the sample in the X and Y directions.

To ensure depths of field between about $115 \mu \mathrm{~m}(4 \times)$ and about $800 \mathrm{~nm}(100 \times)$, the objective $z$-scanners need to be positioned over travel ranges between 100 and $400 \mu \mathrm{~m}$ with a bidirectional position repeatability of 200 nm and in settling times of the order of 20 ms .

Typically, the lateral microscope resolution is in a range of $\geq 250 \mathrm{~nm}$. Therefore, positioning samples in $X Y$ requires a minimum incremental step size and a bidirec-
tional position repeatability in a range of 100 to 200 nm .

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focusing and scanning in $Z$ with nanometer precision >> page 15 et seq.

## U-780 PILine ${ }^{\circledR}$ Piezo Ultrasound Stage System

>> page 26
Customized solutions for sample positioning in upright microscopes available on request.

## Tasks

## Positioning Objectives in $\mathbf{Z}$ - for Autofocus

Positioning Samples in XY - for Sample Scanning

# Life Cell Imaging in Research Microscopy 

Fluorescence, Widefield, Laser Scanning, and Two-Photon Fluorescence Microscopy

The examination of living cells provides fundamental insights into intercellular processes, such as mitosis or the transport of protein molecules or membrane components, and enables investigation of metabolic processes. Different microscopy techniques such as fluorescence, widefield, or laser scanning are used for this purpose. They benefit from nanometer precision positioning of PI motion systems.

For Z stacking, settling times of $<10 \mathrm{~ms}$ in a settling band of a few nanometers are required over a travel range of several hundred micrometers in $Z$. Typically, positioning samples in XY needs a bideractional accuracy of 100 nm or better in a range of $135 \mathrm{~mm} \times$ 85 mm of travel.

In Total Internal Reflection Fluorescence Microscopy (TIRFM) the electromagnetic field of the laser beam penetrates the sample volume and forms an evanescent field with a penetration depth between 100 to 200 nm . As a result, a better $Z$ resolution is achieved, which typically is in the range of $100-200 \mathrm{~nm}$ when compared to about 500 nm from other microscopic techniques.


Image: GATTAquant / PI

## Tasks

Positioning Objectives in Z

Positioning Samples in XY

## Positioning Samples in $\mathbf{Z}$

## Coupling the Laser Beam for Total Internal Reflection Fluorescence <br> (TIRF) Microscopy

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focusing and scanning in $Z$ with nanometer precision $\gg$ page 15 et seq.
U-780 PILine ${ }^{\circledR}$ Piezo Ultrasound Stage System >> page 26
Customized solutions for sample positioning in upright microscopes available on request.
P-736 Plnano $^{\circledR}$ Z Microscope Scanner $\gg$ page 24
P-737 PIFOC $^{\circledR}$ Sample Z Positioner $\gg$ page 24

## Q-545 Q-Motion ${ }^{\circledR}$ Precision Linear Stage

High Forces and Small Design Due to Piezo Motors

- Only 45 mm in width
- Incremental sensors with position resolution
- Vacuum-compatible versions available
- Push/pull force 8 N
- XY combinations without adapter plate possible

Learn more >>

# Multiphoton <br> Fluorescence Microscopy 

For Deep Tissue Examinations

Two-photon (or multiphoton) excitation microscopy is preferably for experiments that require deep penetration of excitation light into living tissue or intact animal specimens. For this reason, laser excitation light is used at double the wavelength to increase the depth of penetration of infrared light into the strongly scattered tissue. Objective positioning systems with greater travel ranges are required for this purpose. Objectives or samples need to be positioned in $Z$ with a settling time of $<20 \mathrm{~ms}$ in a settling band of $\pm 200 \mathrm{~nm}$ and a travel range of some millimeters.

## Tasks

## Positioning Objectives in Z

## Positioning Samples in XY

## PI Solutions

ND72Z2LAQ PIFOC® Objective Scanning System $\gg$ page 17
Customized long travel Voice Coil PIFOC ${ }^{\circledR}$ available on request.
U-780 PILine ${ }^{\circledR}$ Piezo Ultrasound Stage System $\gg$ page 26
Customized solutions for sample positioning in upright microscopes available on request.
P-545 Plnano ${ }^{\circledR}$ XY(Z) Piezo System $\gg$ page 29
M-545 Microscope XY Stage >> page 25
P-736 Pinano ${ }^{\circledR}$ Z Microscope Scanner $\gg$ page 24
P-737 PIFOC ${ }^{\circledR}$ Sample Z Positioner $\gg$ page 24
P-545 Plnano ${ }^{\circledR}$ XYZ Piezo System $\gg$ page 29

## Light-Sheet Fluorescence Microscopy

Planar Illumination for Live Imaging


Light sheet fluorescence microscopy (LSFM) is a technique used for 3-D and live imaging of large specimens over an extended period of time. It uses a unique planar illumination approach which is orthogonal to the observation direction that minimizes photobleaching and phototoxicity of the living specimen.

To examine small organisms such as a zebrafish in agarose gel, the samples are positioned to a few millimeters in XY with a bidirectional repeatability of 100 nm .

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focusing and scanning in Z with nanometer precision >> page 15 et seq.

P-620 - P-629 PIHera Piezo Linear Precision Positioner >> page 28

# Super-Resolution Fluorescence Microscopy 

Surpass the Diffraction Limit in Living Cell Imaging

A number of super-resolution techniques allow the capture of images with a higher resolution than the diffraction limit of light. Techniques such as Scanning Near-Field Optical Microscopy (SNOM), Stimulated Emission Depletion Microscopy (STED), 4PI Microscopy, Stochastic Optical Reconstruction Microscopy (STORM), and Structured Illumination Microscopy (SIM) have achieved improved lateral (XY) resolution down to tens of nanometers. These new approaches have created unprecedented opportunities for investigating the structure and function of living cells.

Positioning solutions in $Z$ have typical travel ranges of $100 \mu \mathrm{~m}$ to $400 \mu \mathrm{~m}$ with a settling time $<10 \mathrm{~ms}$ in a settling band of $\pm 1 \mathrm{~nm}$. The sample is usually positioned $200 \mu \mathrm{~m}$ in three axes with a bidirectional repeatability of 1 nm .


Image: Shutterstock

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focussing and scanning in $Z$ with nanometer precision $\gg$ page 15 et seq.

## P-612.2 XY Piezo Nanopositioning System <br> Compact, with Aperture

- $100 \mu \mathrm{~m} \times 100 \mu \mathrm{~m}$ closed-loop travel range
- Clear aperture $20 \mathrm{~mm} \times 20 \mathrm{~mm}$
- Compact: Footprint $60 \mathrm{~mm} \times 60 \mathrm{~mm}$
- Parallel kinematics for faster response times and higher multi-axis accuracy
Learn more >>
U-751 XY Stage with Piezomotors
- Compact design: Only 32 mm in height, no lead screw ducts or flanged motors
- Direct-measuring linear encoder with 100 nm resolution
- Self-locking, no heat generation at rest, no servo jitter
- Clear aperture $78 \mathrm{~mm} \times 78 \mathrm{~mm}$ (at maximum displacement $65 \mathrm{~mm} \times 65 \mathrm{~mm}$
- Noncontact limit and reference point switches


## Learn more >>

P-541.Z / P-541.T Piezo Z Stages / Z and Tip/Tilt Stages >> page 28
M-227 High-Resolution Linear Actuator with DC Motor

- Min. incremental motion $0.05 \mu \mathrm{~m}$
- Nonrotating end piece
- Subnanometer resolution with optional piezo drive


## Learn more >>

P-736 Plnano ${ }^{\circledR}$ Z Microscope Scanner >> page 24
P-737 PIFOC ${ }^{\circledR}$ Sample Z Positioner $\gg$ page 24

## Stereo Microscopy

Examination of Whole Organs and Creatures

Some application fields require imaging of entire organs or even living beings. Objective and sample positioners that are designed for high loads and long travel ranges of several millimeters are perfect for this purpose.

Objective is not included in scope of delivery.

## Tasks

Positioning Objectives in $Z$

## Positioning Samples in XY

Positioning Samples in Six Axes


## PI Solutions

Customized autofocus Z-scanner with ultrasound drive, more information on request.

U-780 PILine ${ }^{\circledR}$ Piezo Ultrasound Stage System >> page 26
H-811.I2 6-Axis Miniature Hexapod >> page 27

## Digital Slide Scanning

## Digitize Your Glass Slides



Image: gettyimages

Digital slide scanners digitize samples on glass slides at high speeds. For example, digital samples can be used for faster, more reliable, and more efficient work in healthcare, research, and education.

High-dynamics autofocusing requires a maximum depth of field of $115 \mu \mathrm{~m}$ for 4 x objectives, which means a travel range in $Z$ is typically $100-400 \mu \mathrm{~m}$. The settling time of objective positioners needs to be $<10 \mathrm{~ms}$ in a settling band of $\pm 200 \mathrm{~nm}$.

Fast positioning of samples in $\mathrm{X}, \mathrm{Y}$ with a positioning accuracy of 100 nm and variable travel ranges is necessary, depending on the number and size of the inserted slides.

## PI Solutions

P-725.xDD PIFOC ${ }^{\circledR}$ High-Dynamics Piezo Scanner >> page 18
P-726 PIFOC ${ }^{\circledR}$ High-Load Objective Scanner >> page 18
P-725KHDS PIFOC ${ }^{\circledR}$ Objective Scanner with High Dynamics >> page 18

U-780 PILine ${ }^{\circledR}$ Piezo Ultrasound Stage System >> page 26
V-738 PIMag ${ }^{\circledR}$ High-Precision XY Stage $\gg$ page 25

## Atomic Force Microscopy (AFM)

In Combination with Raman or Scanning Near-field Optical Microscopy (SNOM)

Atomic Force Microscopy (AFM) delivers topographical information of the sample, e. g., minerals, polymer mixtures, composite materials, or biological tissue. Confocal Raman Imaging identifies the chemical components. Scanning Near-field Optical Microscopy (SNOM) is used for optical imaging with resolution beyond the diffraction limit. All three methods can be combined in one system (correlative microscopy), thanks to the parallel-kinematic piezo stage with fast response time and high multi-axis accuracy. Positioning accuracy of down to 1 nm and below is demanded in all three axes.


Images: WITec

## Tasks

Positioning Samples in XYZ

## Positioning Samples in XY

## PI Solutions

Customized solutions available on request.
P-517 / P-527 Multi-Axis Piezo Scanner >> page 29

## Scanning Electron Microscopy (SEM)

Examination in UHV Environment

Electron microscopy allows investigation with extremely high lateral resolution down to a range of $<1$ nanometer. Demands on positioning systems subsequently comprise respective resolution, additionally stages have to be nonmagnetic and UHV compatible ( $10^{-7} \mathrm{hPa}$ ). Based on these features, positioning solutions from PI can also be deployed in Focused lon Beam (FIB) systems and in combined FIB/SEM machines.


Image: Dr. Reiner Ramlau, MPI for chemical physics of solid materials


Positioning Samples in XY

## PI Solutions

## U-751 XY Stage with Piezomotors

- Compact design: Only 32 mm in height, no lead screw ducts or flanged motors
- Direct-measuring linear encoder with 100 nm resolution
- Self-locking, no heat generation at rest, no servo jitter
- Clear aperture $78 \mathrm{~mm} \times 78 \mathrm{~mm}$ (at maximum displacement $65 \mathrm{~mm} \times 65 \mathrm{~mm}$ )
- Noncontact limit and reference point switches


## Learn more >>

## P-752 High-Precision Nanopositioning Stage

- Travel range to $35 \mu \mathrm{~m}$
- Resolution 0.1 nm
- Rapid response
- Highest linearity due to capacitive sensors Learn more >>


## Industrial Inspection

Optical 3-D Surface Measuring Technology

The trend in surface inspection is moving towards smaller and smaller structures that must be reproduced or resolved accurately at nanometer level. Optical measuring processes are employed for many applications because they can be applied to almost all materials and are also suitable for sensitive samples. Highly precise, confocal reproduction principles can present the sample topography and roughness structures not only qualitatively, but also quantitatively using matching tactile measuring methods that are described in many industry standards. Piezo-based positioning systems are making considerable contributions in this field because they offer nanometer precision and high dynamics.


Images: NanoFocus

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focusing and scanning in $Z$ with nanometer precision >> page 15 et seq.
P-620.1 - P-629.1 PIHera Piezo Linear Precision Positioner >> page 28
P-541 / P-517 / P-561 / P-562 Tracking and Scanning for Super-Resolution >> page 28 / 29 / 30

- Parallel kinematics for faster response times and higher multi-axis accuracy
- Travel ranges to $300 \times 300 \times 300 \mu \mathrm{~m}$
- Subnanometer resolution


## 3-D Surface Inspection

White Light Interferometry


The contours and roughness of surfaces can be analyzed in real time at picometer resolution by employing noncontact, and nondestructive methods. For this purpose, high-resolution camera systems are combined with white light interferometry.

Fast and precise positioning of lenses is an important requirement for detailed analysis of the surface and for piecing individual measurement results together to produce meaningful images.

The position of the lens must be matched accurately to the individual image and only then is high-precision 3-D surface inspection possible.

| Tasks |
| :--- |
| Positioning Objectives in Z |
|  |
| Positioning Samples in XY |
| Positioning Samples in Six Axes |

## PI Solutions

PIFOC ${ }^{\circledR}$ Objective Scanners for focusing and scanning in $Z$ with nanometer precision $\gg$ page 15 et seq.

L-731 Precision XY Stage >> page 25
H-811.l2 6-Axis Miniature Hexapod >> page 27

## Find Your Piezo Z-Nanopositioner

With Aperture


# PIFOC® Objective Scanners 

Focusing and Z-Stack Scanning with Nanometer Precision

Objective scanners of the PIFOC ${ }^{\circledR}$ series offer high dynamics in positioning and scanning tasks. Well adapted solutions for $Z$ focusing of the objective are available as standard products, also as system packages with controller and software. Like all piezo systems, scanners are delivered precalibrated with measurement log.

- Significantly faster response and higher lifetime than stepper- or DC motor drives
- Nanometer precision and settling times in the range of milliseconds
- In combination with capacitive sensors highest linearity due to direct measuring technology
- High guiding accuracy due to zero-play flexure guides
- Clear aperture up to $\emptyset 29 \mathrm{~mm}$
- QuickLock thread adapters for easy installation >> page 19
- Spacers available to adapt additional objectives without PIFOC ${ }^{\circledR}$ in the same objective nosepiece, refer to >> page 19


## P-725 PIFOC ${ }^{\circledR}$ Objective Scanners

 with Long Travel Ranges up to $400 \mu \mathrm{~m}$System packages also available incl. QuickLock thread adapter, controller and software >> page 16.

## P-721 PIFOC ${ }^{\circledR}$ High-Precision

Objective Scanners with Travel Ranges up to $\mathbf{1 0 0} \boldsymbol{\mu m}$ System packages also available incl. QuickLock thread adapter, controller and software >> page 16.

Objective is not included in scope of delivery.
QuickLock thread adapter to be ordered separately according to >> page 19 et seq.
Recommended electronics >> page 32

## Technology: PICMA ${ }^{\oplus}$ Multilayer Piezo Actuators

PICMA ${ }^{\oplus}$ actuators take advantage of the indirect piezoelectric effect and achieve high forces. They only need a small amount of installation space. At the same time, the PICMA ${ }^{\oplus}$ actuators are very dynamic and can reach a position with an unprecedented precision. Due to their ceramic insulation, PICMA $^{\circledR}$ actuators exhibit high reliability and climate resistance.

## Fast PIFOC ${ }^{\circledR}$ Objective Scanning Systems

High Dynamics Piezo Drive for Subnanometer Resolution

- Fine positioning of objectives with sub-nm resolution
- Direct metrology with capacitive sensors (depending on model)
- Compatible with LabVIEW, $\mu$ Manager and MATLAB
- All servo-control parameters can be changed during operation
- Models with large aperture Ø 29 mm available
- USB, RS-232, analog interfaces


PD72Z1x PIFOC ${ }^{\circledR}$
Objective Scanning System with $\mathbf{1 0 0} \boldsymbol{\mu m}$ Travel Range $\qquad$
PD72Z2x * PD72Z4x PIFOC ${ }^{\circledR}$
Objective Scanning System with $400 \mu \mathrm{~m}$ Travel Range


## Systems include

- PIFOC ${ }^{\circledR}$ Objective Scanner
- E-709 Digital Controller
- QuickLock-Thread adapter M25 $\times 0.75$ or M32 $\times 0.75$ for PIFOC ${ }^{\circledR}$ with large aperture $\gg$ page 19 et seq.
- PIMikroMove ${ }^{\circledR}$ Software
- Drivers for LabVIEW, Matlab, C++ and more


## Long Travel PIFOC ${ }^{\circledR}$ Objective Scanning System

## Nanometer Resolution and Fast Step-and-Settle

## ND72Z2LAQ PIFOC ${ }^{\circledR}$ Objective Scanning System $2000 \mu \mathrm{~m}$

$\square$
Nanometer Resolution and Fast Step-and-Settle

- Complete system with digital controller, software, and M32 QuickLock thread adapter
- USB, RS-232
- Sensor resolution 0.5 nm
- Highly dynamic step-and-settle for Z stacks
- Further thread adapters as optional accessory
- Compatible with $\mu$ Manager, LabVIEW, and MATLAB
- Parameter changing during operation


Further QuickLockThread adapters available, see >> page 19 Further electronics and accessories available on request.

## Systems include

- PIFOC ${ }^{\circledR}$ Objective Scanner
- E-861 Digital Servo Controller
- P-721.05Q QuickLock-Thread adapter M32 $\times 0.75$
- PIMikroMove ${ }^{\circledR}$ Software
- Drivers for LabVIEW, Matlab, C++ and more

Nanometer precision and high feed force with PiezoWalk ${ }^{\circledR}$ walking drives
Several piezo actuators perform a walking motion in the PiezoWalk ${ }^{\circledR}$ walking drive that leads to forward feed of a runner. Control of the actuators allows the smallest step and forward feed motion at a resolution of well under one nanometer.

# High-Dynamics and High-Load PIFOC ${ }^{\circledR}$ Objective Scanners 

## Nanometer Resolution for Heavy Objectives

## P-725.xDD PIFOC ${ }^{\circledR}$ High-Dynamics Piezo Scanner <br> 

- Travel range $18 \mu \mathrm{~m}$, shortest settling time $<5 \mathrm{~ms}$ with microscope objective
- Scans and positions objectives with sub nm resolution
- Parallel flexure guiding for minimized objective offset
- Direct metrology with capacitive sensors for highest linearity
- Cost-efficient version with SGS sensors
- Compatible with MATLAB, LabVIEW and $\mu$ Manager
- Outstanding lifetime due to PICMA ${ }^{\oplus}$ piezo actuators
- QuickLock adapter for easy attachment



## P-726 PIFOC ${ }^{\circledR}$ High-Load Objective Scanner

- Highly dynamic positioning and scanning for large objectives
- Resonant frequency $1120 \mathrm{~Hz}, 560 \mathrm{~Hz}$ with 210 g objective mass
- Typ. settling time of about 6 ms
- Travel range $100 \mu \mathrm{~m}$
- Direct-metrology capacitive sensors for best linearity, stability and control dynamics
- Resolution 0.3 nm
- Zero-play, high-precision flexure guide system for better focus stability

[^0]

## Configuration Diagram for PIFOC ${ }^{\circledR}$ Objective Scanners with Standard Aperture



## Configuration Diagram for PIFOC ${ }^{\circledR}$ Objective Scanners with Large Aperture

Aperture up to 29 mm, Depending on Thread Adapter
of delivery
To be orderd seperately
 PIFOCS ${ }^{\circledR}$ WITH CLEAR APERTURE Ø 29 MM
P-721.05A
$\mathrm{M} 32 \times 0.75$


P-721.11A
$\mathrm{M} 25 \times 0.75$
P-721.02A
$\mathrm{M} 26 \times 0.75$
P-721.03A
$\mathrm{M} 27 \times 0.75$
P-721.04A
$\mathrm{M} 28 \times 0.75$

## P-721.06A

$\mathrm{M} 26 \times 1 / 36^{\prime \prime}$

PIFOC ${ }^{\circledR}$ OBJECTIVE SCANNING SYSTEM
WITH CLEAR APERTURE $\varnothing 29$ MM
WITH CAPACITIVE SENSORS
PD72Z1CAA
$100 \mu \mathrm{~m}$ travel range
PD72Z2CAA
$250 \mu \mathrm{~m}$ travel range
PD72Z4CAA
$400 \mu \mathrm{~m}$ travel range

ELECTRONICS FOR SYSTEMS WITH CAPACITIVE SENSORS
Cost efficient: E-709.CRG Digital piezo controller, 1 axis, -30 to 130 V , capacitive sensor, benchtop device

For high dynamic applications:
E-709.CHG
Digital piezo controller, 1 channel, -30 to 130 V , capacitive sensor, high power output, benchtop device

For highest demands:
E-754.1CD
Single-channel, digital high-speed piezo controller for capacitive sensors, with TCP/IP, USB, and RS-232 interface

PIFOC ${ }^{\circledR}$ OBJECTIVE SCANNING SYSTEM
WITH CLEAR APERTURE Ø 29 MM
WITH STRAIN GAUGE SENSORS
PD72Z1SAA
$100 \mu \mathrm{~m}$ travel range

ELECTRONICS FOR SYSTEMS WITH STRAIN GAUGE SENSORS E-709.SRG
Digital piezo controller, 1 axis, -30 to 130 V , strain gauge sensor, benchtop device


## Configuration Diagram for P-726 PIFOC ${ }^{\circledR}$

High-Load Objective Scanner

$\square$ Links to detailed product webpages (PIFOC / Controllers) can be found on the respective product pages of this brochure.

## Sample Positioning in Several Axes

## Product Selector




## Sample Positioning in Z

## Low Profile and Clear Aperture

PD73Z2xOW PInano ${ }^{\circledR}$ Z Microscope Scanner System for Microtiter Plates<br>Large Clear Aperture, Low Profile, with Digital Controller<br>- For Inverted Olympus Microscopes<br>- Fast step \& settle<br>- Clear aperture for well plates and low profile for easy integration<br>- Travel range $220 \mu \mathrm{~m}$<br>- Outstanding lifetime due to $\mathrm{PICMA}^{\oplus}$ piezo actuators<br>- Piezoresistive sensors for lower cost<br>- Capacitive sensors for higher stability




P-736 PInano ${ }^{\circledR}$ Z Microscope Scanner System
Inexpensive, with Low Profile

- Low overall height of 20 mm for easy integration
- Travel range $100 \mu \mathrm{~m}$ or $200 \mu \mathrm{~m}$
- Clear aperture $93 \mathrm{~mm} \times 65 \mathrm{~mm}$
- E-709 digital piezo servo controller in the scope of delivery
- USB, RS-232, analog interfaces
- Compatible with MATLAB, LabVIEW and $\mu$ Manager


## Systems include

- Plnano ${ }^{\circledR}$ Z piezo scanner
- E-709 digital servo piezo controller
- Extensive software package



## P-737 PIFOC ${ }^{\circledR}$ Specimen $Z$ Positioner

With Large Aperture and Low Profile

- Travel ranges to $500 \mu \mathrm{~m}$
- Clear aperture $128.5 \mathrm{~mm} \times 86.5 \mathrm{~mm}$ to accommodate well plates
- Low profile 20 mm
- Compatible with MATLAB, LabVIEW and $\mu$ Manager


## Sample Positioning for Widefield Microscopy

## Compact and Fast



N-565 Linear Stage with the Highest Precision
NEXACT ${ }^{\oplus}$ Piezo Walking Drive with Subnanometer Encoder Resolution

- Long travel ranges: $13 \mathrm{~mm}, 26 \mathrm{~mm}$ or 52 mm
- Ultraprecision: 2 nm minimum incremental motion and directmeasuring PIOne encoder with 0.5 nm resolution
- Compact design: 65 mm width, 20 mm height


## U-521 PILine ${ }^{\circledR}$ Linear Stage

Compact Linear Stage with Ultrasonic Piezo Motor

- Travel ranges to $25 \mathrm{~mm} \times 25 \mathrm{~mm}$
- Positions small loads quickly and with precision: Velocity to $200 \mathrm{~mm} / \mathrm{s}$, minimum incremental motion to $0.3 \mu \mathrm{~m}$
- Space-saving: Only 35 mm in width and 15 mm in height



## M-545 Microscope XY Stage



Compact, Stable, Long Travel Range

- Travel range $25 \mathrm{~mm} \times 25 \mathrm{~mm}$
- Stable platform for P-545 PInano ${ }^{\circledR}$ piezo nanopositioning systems
- Low profile for easy integration: 30 mm
- Manual operation with micrometer screws, optional motorization with stepper mike actuators
- For inverted microscopes from Nikon, Zeiss, Leica, and Olympus


## V-731 / V-741 PIMag ${ }^{\text {® }}$ High-Precision XY Stage

High Travel Accuracy and Stability, Magnetic Direct Drive*

- Travel range $205 \mathrm{~mm} \times 205 \mathrm{~mm}\left(8^{\prime \prime}\right)$ or $305 \mathrm{~mm} \times 305 \mathrm{~mm}$ (12")
- Bidirectional repeatability to $\pm 0.25 \mu \mathrm{~m}$
- Velocity to $200 \mathrm{~mm} / \mathrm{s}$
- Ironless 3-phase linear motor
- Incremental linear encoder with 1 nm resolution




## V-738 PIMag ${ }^{\text {® }}$ High-Precision XY Stage

Clear Aperture, High Travel Accuracy and Stability, Magnetic Direct Drive*

- Travel range $102 \mathrm{~mm} \times 102 \mathrm{~mm}$ (4")
- $150 \mathrm{~mm} \times 150 \mathrm{~mm}$ open frame (in reference position)
- Bidirectional repeatability to $\pm 0.25 \mu \mathrm{~m}$
- Velocity to $500 \mathrm{~mm} / \mathrm{s}$
- 3-phase linear motor
- Incremental linear encoder with 1 nm resolution


## Sample Positioning for Widefield Microscopy

## Compact and Fast with Nanometer Resolution

## Extensive Functions, Software Support

Powerful macro command language. Nonvolatile macro storage, e.g., for stand-alone operation with autostart macro. Data recorder. ID chip detection for fast startup. PID controller, parameter changing during operation. Extensive software support, e.g., for LabVIEW, C, C++, MATLAB, $\mu$ Manager. PIMikroMove user software.

## U-780 PILine ${ }^{\circledR}$ XY Stage

System with Controller and Joystick

- High velocity constancy at $10 \mu \mathrm{~m} / \mathrm{s}$
- Velocity to $120 \mathrm{~mm} / \mathrm{s}$, bidirectional repeatability $0.3 \mu \mathrm{~m}$
- Travel range to $135 \mathrm{~mm} \times 85 \mathrm{~mm}$ (depending on model type)
- Compact, flat design: Unrestricted access to the sample
- Suitable for the following inverted microscopes:
- Nikon Eclipse Ti-E/Ti-U/Ti-S
- Olympus IX2
- Leica DMI

Systems include

- PILine ${ }^{\circledR}$ XY Stage
- C-867.2U2 Piezomotor controller
- USB joystick
- Extensive software package

PILine ${ }^{\circledR}$ Ultrasonic Piezomotor
An integral part of a PILine ${ }^{\circledR}$ ultrasonic piezomotor is a piezo actuator that is preloaded against a movable, guided runner via a coupling element. The piezoceramic actuator is excited to ultrasonic oscillation by a high-frequency AC voltage between 100 and 200 kHz . Deformation of the actuator leads to periodic diagonal motion of the coupling element relative to the runner. The feed created is a few nanometers per cycle; the high frequencies lead to the high velocities. Preloading the piezoceramic actuator against the runner ensures self-locking of the drive when at rest and switched off.

## Sample Positioning for Widefield Microscopy

## Parallel-Kinematic Designs for Positioning in up to 6 Axes



## H-811.I2/I2V 6-Axis Miniature Hexapod

$\square$
Fast, Compact, and Highly Precise

- Travel ranges to $\pm 17 \mathrm{~mm} / \pm 21^{\circ}$
- Load capacity to 5 kg
- Repeatability to $\pm 0.06 \mu \mathrm{~m}$
- Velocity to $20 \mathrm{~mm} / \mathrm{s}$
- Superior lifetime
- Vacuum-compatible versions available


## H-825 6-Axis Hexapod

- Load capacity to 30 kg , self-locking
- Travel ranges to $\pm 27.5 \mathrm{~mm}$, rotation range to $\pm 11.5^{\circ}$
- Actuator resolution to 8 nm
- Minimum incremental motion to $0.25 \mu \mathrm{~m}$ in $\mathrm{X}, \mathrm{Y}$, and Z
- Repeatability to $\pm 0.1 \mu \mathrm{~m} / \pm 2 \mu \mathrm{rad}$
- BLDC motors and absolute encoders


In a parallel-kinematic hexapod all drives act on a single moving platform, which results in a much more compact design than possible with stacked systems. Compared to a serial robot, hexapods show a much better ratio of payload to operating weight. As only one platform is moved, the overall moved mass is lower resulting in higher dynamics in all motion axes. Serial motion and positioning platforms have their advantages in the high modularity which allows for individual design of each moving axes. Motion control, especially the homing procedure, is simpler with no coordinate transformation required. On the other hand, the combined positioning errors of stacked systems affect the attainable overall system accuracy. Hexapods can have an improved path accuracy, higher repeatability and flatness of travel.


## Sample Positioning for Super-Resolution Methods

## Tracking and Scanning



P-753 LISA Linear Actuator and Stage
Dynamic and Stable in Position

- Travel range to $38 \mu \mathrm{~m}$
- Resolution 0.05 nm
- Guided stage and actuator at the same time
- Particularly fast response behavior due to direct drive
- Highest linearity due to capacitive sensors

P-620 - P-629 PIHera Piezo Precision Positioner
Variable Travel Ranges and Axis Configuration

- Travel ranges 50 to $1800 \mu \mathrm{~m}$
- Resolution to 0.1 nm
- Linearity error 0.02 \%
- X, XY, Z versions; XYZ combination possible
- Vacuum-compatible versions to $10^{-9} \mathrm{hPa}$


P-541.Z / P-541.T Piezo Z Stages / Z and Tip/Tilt Stages

- Travel range to $150 \mu \mathrm{~m}$
- Clear aperture $80 \mathrm{~mm} \times 80 \mathrm{~mm}$
- Low profile for easy integration: 16.5 mm
- Tip/tilt angle to 1.2 mrad
- Parallel kinematics for faster response times and higher multi-axis accuracy

■ Sensor technology: Inexpensive strain gauge sensors or capacitive sensors for higher performance

- Combination with microscope stages possible for long travel ranges



## Sample Positioning for Super-Resolution Methods

## Tracking and Scanning

## P-733 XY(Z) Piezo Nanopositioner <br> $\square$

- Travel ranges to $100 \mu \mathrm{~m} \times 100 \mu \mathrm{~m}$ and to $10 \mu \mathrm{~m}$ in Z
- Resolution to 0.1 nm due to capacitive sensors
- High-speed versions with direct drive
- Vacuum-compatible and non-magnetic versions available
- Parallel kinematics for higher accuracy and dynamics


P-517 / P-527 Multi-Axis Piezo Scanner
High Dynamics Nanopositioner / Scanner with Direct Position Measuring

- Travel ranges to $200 \mu \mathrm{~m}$
- Subnanometer resolution
- 2- and 3-axis versions (XY and $X Y \theta_{z}$ )


## P-545 Plnano ${ }^{\circledR}$ Piezo XY(Z) Systems

- Subnanometer resolution and fast response in the ms range
- Low profile for easy integration: 20 mm
- E-727 USB controller and software included
- Extensive optional accessories >> page 31


## P-545.3D8S PInano ${ }^{\circledR}$ Trak Piezo Tracking System

- Travel ranges to $70 \mu \mathrm{~m} \times 70 \mu \mathrm{~m} \times 50 \mu \mathrm{~m}$

P-545.xR8S Plnano ${ }^{\circledR} X Y(Z)$ Piezo System


- Travel ranges to $200 \mu \mathrm{~m} \times 200 \mu \mathrm{~m} \times 200 \mu \mathrm{~m}$
- Inexpensive cost-optimized design due to piezoresistive sensors

Recommended electronics >> page 33

Excellent Guiding Accuracy Through Flexure Joints
Flexure guides are free of maintenance, friction, and wear, and do not require lubrication. Their stiffness allows high load capacity and they are insensitive to shock and vibration. They are $100 \%$ vacuum compatible and work in a wide temperature range.

## Sample Positioning for Super-Resolution Methods

Tracking and Scanning

P-561 / P-562 / P-563 PIMars Nanopositioning Stage
 High-Precision Nanopositioning System for up to 3 Axes

- Travel ranges to $300 \times 300 \times 300 \mu \mathrm{~m}$
- Parallel kinematics for faster response times and higher multi-axis accuracy

P-562.6CD PIMars 6-Axis Piezo Stage System

## -

High-precision Nanopositioning System with 6 Degrees of Freedom

- Travel ranges to $200 \mu \mathrm{~m}$ linear and to 1 mrad tip/tilt angle
- Clear aperture $66 \mathrm{~mm} \times 66 \mathrm{~mm}$
- Excellent scanning flatness
- Parallel kinematics for faster response times and higher multi-axis accuracy



## P-616 NanoCube ${ }^{\circledR}$ Nanopositioner



- Travel ranges to $110 \times 110 \times 110 \mu \mathrm{~m}$
- Ultra-compact: $40 \mathrm{~mm} \times 40 \mathrm{~mm} \times 40 \mathrm{~mm}$
- Resolution to 0.3 nm
- Highly dynamic motion due to high resonant frequencies even with loads up to 100 g
- Only nanopositioner available on the market with ID chip functionality


## Accessories for Sample Positioning Stages

Compatibility of Piezo Scanners with Manual，Motorized and PILine ${ }^{\circledR}$ XY Microscope Stages

|  |  |  |  |  |  |  |  |
| :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: |
| U－780．DNS <br> PILine ${ }^{\circledR}$ XY stage system for Nikon microscopes | － | － |  |  |  | － | － |
| U－780．DOS <br> PILine ${ }^{\circledR}$ XY stage system for Olympus microscopes | $\bullet$ |  | － |  |  | － | － |
| U－780．DLS <br> PILine ${ }^{\circledR}$ XY stage system for Leica microscopes | － |  |  |  |  | － | － |
| M－545．2MN <br> XY stage for Nikon microscopes TI series | － |  |  | －＊ | －＊＊ | － |  |
| M－545．2MO <br> XY stage for Olympus microscopes IX2，IX3 | － |  |  | －＊ | －＊＊ | － |  |
| M－545．2ML <br> XY stage for Leica microscopes DMI series | $\bullet$ |  |  | －＊ | －＊＊ | － |  |
| M－545．2MZ <br> XY stage for Zeiss microscopes Axio Observer | － |  |  | －＊ | －＊＊ | － |  |

＊With P－736．AP1 adapter plate／＊＊With P－733．AP1 adapter plate

Inserts for PI Sample Stages

|  |  |  |  |  |  －广誌 id id |  | 2 0 0 ion $j$ $j$ | $\begin{aligned} & \text { O } \\ & \text { Ò } \\ & \text { © } \\ & \dot{j} \end{aligned}$ |  |  |
| :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: |
| Microscope slide holder | P－545．SH3＊ | P－736．SHN＊ | P－736．SHO＊ | P－545．SH3＊ |  | P－737．AP1＊ | $\begin{aligned} & \text { P-736.SHN* } \\ & \text { P-736.SHO* } \end{aligned}$ | P－736．SHN＊ P－736．SHO＊ | $\begin{aligned} & \text { P-736.SHN* } \\ & \text { P-736.SHO* } \end{aligned}$ | P－545．SH3＊ with M－545．SHP |
| Petri dish holder | P－545．PD3 | P－736．PDN | P－736．PDO | P－545．PD3 | P－542．PD1 | P－737．AP2 | $\begin{aligned} & \text { P-736.PDN } \\ & \text { P-736.PDO } \end{aligned}$ | P－736．PDN <br> P－736．PDO | $\begin{aligned} & \text { P-736.PDN } \\ & \text { P-736.PDO } \end{aligned}$ | ```P-545.PD3 with M-545.SHP adapter plate``` |
| Microtiter plate holder |  | P－736．WPN | P－736．WPO |  | P－542．SH1＊ |  | P－736．WPN P－736．WPO | P－736．WPN <br> P－736．WPO | P－736．WPN <br> P－736．WPO |  |
| Universal holder |  | P－736．UHN＊ | M－687．AP1＊ |  |  |  | $\begin{aligned} & \text { P-736.UHN* } \\ & \text { M-687.AP1* } \end{aligned}$ | $\begin{aligned} & \text { P-736.UHN* } \\ & \text { M-687.AP1* } \end{aligned}$ | $\begin{aligned} & \text { P-736.UHN* } \\ & \text { M-687.AP1* } \end{aligned}$ |  |
| Universal holding plate | P－545．PP3 |  |  | P－545．PP3 |  |  |  |  |  | P－545．PP3 with M－545．SHP |

M－545．SHP adapter plate
＊Also available：P－545．C18 Coverslip holder（for $18 \mathrm{~mm} \times 18 \mathrm{~mm}$ coverslips），
P－545．C22（for $22 \mathrm{~mm} \times 22 \mathrm{~mm}$ coverslips）and P－545．C25（for $25 \mathrm{~mm} \times 25 \mathrm{~mm}$ coverslips）

## Single Channel Digital Controllers

Plug-and-Play via Extensive Software Package


## E-709 Compact and Cost-Optimized Digital 1-Channel Piezo Controller

- Linearity error to 0.02 \%
- Comprehensive I/O functions
- Fast 25 Mbit/s serial interface USB, digital RS-232, fast serial interface with up to $25 \mathrm{MBit} / \mathrm{s}$

E-709.CHG Digital 1-Channel Piezo Controller for High Dynamic Applications<br>- Output power up to 50 W<br>- Linearity error to 0.02 \%<br>- USB, RS-232<br>- SPI: Fast 25 Mbit/s serial interface<br>- Comprehensive I/O functions



## E-754 Digital 1-Channel Piezo

Controller for Highest Demands

- Next generation digital controller provides higher flexibility, accuracy, and speed
- Analog inputs and outputs
- Autoloading of calibration data from stage ID chip for interchangeability of controller and mechanics
- Digital I/O lines for task triggering

Further compatible electronics (e. g. analog controllers or OEM modules) available on request.


Extensive software for rapid start of productive operation
Thanks to support of MATLAB and LabVIEW as well as all common operating systems (Windows, Linux, and macOS), integration succeeds in virtually every environment - quickly and efficiently. Sophisticated programming examples and software tools such as PIMikroMove shorten the time to productive operation considerably.

## Multi-Channel Digital Controllers



## E-727 Digital Multi-Channel Piezo Controller

$\square$
For Nanopositioning Systems with Capacitive, Piezoresistive or Strain Gauge Sensors

- 20 kHz control bandwidth
- Interfaces: Ethernet, USB, RS-232, SPI
- Digital inputs and outputs
- Optional analog inputs and outputs
- Autoloading of calibration data from stage
- ID chip for interchangeability of controller and mechanics
- $4^{\text {th }}$ order polynomial linearization for mechanics and electronics


## E-712 Digital Piezo Controller



Modular System for up to 6 Axes for Highest Precision

- Up to 50 kHz servo update rate
- Highly stable 20-bit D/A converter
- Real-time operating system for excellent trajectory control
- Autoloading of calibration data from stage ID chip for interchangeability of controller and mechanics
- Flexible interfaces:TCP/IP, USB, RS-232; optional broadband analog inputs and outputs
- Extensive software package



## C-887.52x Hexapod Motion Controller

Compact Bench-Top Device for Controlling 6-Axis Systems

- Sophisticated controller using vector algorithms
- Commanding in Cartesian coordinates
- Easy customization of coordinate systems by command
- Analog interfaces and motion stop optional
- Extensive software package


## Multi-Channel Digital Controllers

Plug-and-Play via Extensive Software Package


## SMC Hydra Universal Motion Controller

For electromagnetic motors, DC servo and brushless
DC motors (BLDC), linear and torque motors
(2 / 3 phases), 2-phase stepper motors

- 2-D vector motion
- Digital inputs and outputs
- Optional: Encoder-based trigger output, Dynamic position correction
- Joystick operation via CAN bus



## The PI Group

## A Strong Partner for Industry and Research



PI (Physik Instrumente) has been one of the leading players in the global market for precision positioning technology for many years. The technological diversity of the PI Group is unique all over the world. PI develops, manufactures, and qualifies all its core technologies itself. Pl is therefore not dependent on components available on the market to offer its customers the most advanced solutions.

The complete control over vertically linked manufacturing processes allows flexible reaction to market developments and new requirements.

Modern organizational forms such as the fractal production model guarantee efficient production for batch sizes of 1, small series, and also OEM products in large quantities. By acquiring the majority shares in ACS Motion Control, a worldwide leading developer and manufacturer of modular motion controllers for multi-axis drive systems, PI can also offer solutions from one single source to meet the industry's increasing demands on precision and throughput.

The foremost priority for Pl is to be a reliable and highly qualified partner for the customer.

## Core Technologies

- In-house manufacturing of piezo components and piezo actuators
- Magnetic direct drives: linear motors and voice coils
- Air bearings, magnetic and flexure guides
- Comprehensive range of piezo motor technologies
- Nanometrology sensors
- Parallel-kinematic systems for positioning in six axes (Hexapods)
- Motion control technology
- Software



## From 1-off to Series: OEM Customers Benefit From Maximum Flexibility

PI serves both the research and industrial markets. The complete control over the design and manufacturing process provides our customers with significant competitive advantages. Optimized processes allow PI to deliver customized products in quantities up to several 100,000 units per year at low cost and right on time. The range of OEM products offered by the PI Group varies widely, ranging from "bare" actuators and sensors to highly integrated parallel-kinematic positioning systems. Evaluation of pre-production run samples, test procedures, production processes and quality management are all included in the development process.

## Services

- Global account management: Close proximity to the customer thanks to international presence
- Risk assessment from design to delivery
- Depending on the task: From the drive to the turnkey system
- Copy exactly policy
- Preparation of internal and external certification
- Production of series of several 10,000 units in the shortest time
- Sustainable spare parts service
- Manufacturing and testing capacities from functional samples to mass production


Standardized performance control with full documentation of individual measurement charts

## Global Service and After-Sales



On-site training is key to optimize and maximize the potential of new PI systems

## Start-Up, User Training and Life Long Support

PI is dedicated to supporting its customers right from the initial consultation through to when a customer has purchased a Pl system. Beyond that, PI's services division is committed to ensuring that every aspect of owning a PI system is catered for.

## Global Coverage

Supported by 4 Global Service Hubs in Asia, China, Europe and USA, with field product specialists working from these hubs, PI is able to support all technologies and customer applications via this global services team.

## PI's Standard On-Site Services

- Set up and Commissioning - On-site support to un-box, set-up and commission the PI system
- Training Program - User training on software and programming, through to optimization of system performance
- Maintenance Systems Health Check - Preventative maintenance to prolong the life of the motion device
- Support - Ongoing remote and on-site support to maximize system uptime and provide maintenance for the whole life of any system


## Contracted Services

Customers subscribing to Contractual Support Services will receive commitment from Pl to achieving agreed Service Levels. These include responding to the customer's first contact and providing remote technical support, through to response times for a PI expert to be on site, either to repair or replace a defective unit.

## Extended Warranty

Most customer applications require PI's systems to be operational beyond the standard warranty period. Extending the warranty for additional year(s), is simply extending the customers peace of mind and PI's commitment that the product will not fail due to poor workmanship or faulty materials. Should a customer's system then fail due to these conditions, PI will cover the costs to repair or replace it.

## The PI Group Milestones

## A Success Story

PI has been developing and manufacturing standard and OEM products with piezo or motor drives for more than 40 years. Continuous development of innovative drive concepts, products, and system solutions and more than 200 technology patents distin-
guish the company history today. In addition to four locations in Germany, the PI Group is represented internationally by fifteen sales and service subsidiaries. PI is a privately owned company with healthy growth and more than 1000 employees worldwide.


Market introduction of the PICMA ${ }^{\oplus}$ multilayer piezo actuators



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[^0]:    P-725KHDS PIFOC ${ }^{\circledR}$
    Objective Scanner with High Dynamics

    - Travel range $400 \mu \mathrm{~m}$
    - Step-and-settle 20 ms , with 400 g load
    - Resonant frequency 120 Hz , with 400 g load
    - QuickLock thread adapters up to M32

